Inverted Research Microscope TE2000 Accessories



Accessories

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TE2000



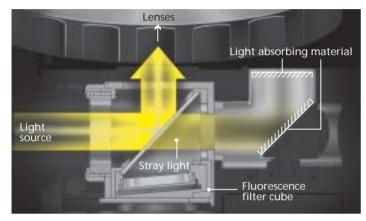
CF60

Epi-fluorescence

Nikon's exclusive Noise Terminator mechanism thoroughly eliminates the possibility of stray light to produce images of greater S/N ratio when observing weakly fluorescing specimens especially in dynamic live cell imaging experiments.

Noise Terminator

Nikon's innovative two-step process discharges stray light from the filter cube to vastly improve the optical S/N.







Turret-type filter changer Holds up to six filter cubes. Manual or motorized filter changing is provided as well as the option for an automated internal vibration-free shutter.



Epi-fluorescence set

- Epi-fl Attachment
- 2 Epi-fl Collector Lens
- Mercury Lamp Socket and Mercury Lamp
- 4 Epi-fl Filter Cubes and Dummy Cassette
- G Centering Tool for Light Source
- 6 Light Shielding Plate
- Starter for Mercury Lamp
- 8 Epi-fl Filter Rotating Turret
- O ND Filters
- Hand Switch
- FL Zoom Illumination

Aperture

Plan Fluor & S Fluor objectives

The CFI60 Plan Fluor ELWD objective series can be used universally for phase contrast, epi-fluorescence, Nomarski DIC, as well as brightfield observations, with the same, consistently high optical performance.

CFI Plan Fluor DL 4X

- 2 CFI Plan Fluor DL 10X
- 3 CFI Plan Fluor ELDW DM 20X C
- O CFI Plan Fluor ELDW DM 40XC
- 6 CFI Plan Fluor 10X
- 6 CFI Plan Fluor ELWD 20X C
- CFI Plan Fluor ELWD 40X C
- 8 CFI S Fluor 10X
- CFI S Fluor 20X
- CFI S Fluor 40X
- CFI S Fluor 40X oil



CF epi-fl collector lens

This collector lens maintains constantly even illumination even when excitation light is being switched from UV to G or vice versa, greatly expediting FISH and other observations of multi-color stained specimens.

Nomarski DIC

By changing the material structure, Nikon developed a standard prism with a perfect balance of contrast and resolution at any magnification. Depending upon the type of specimen, a high-contrast or high-resolution prism is also available.





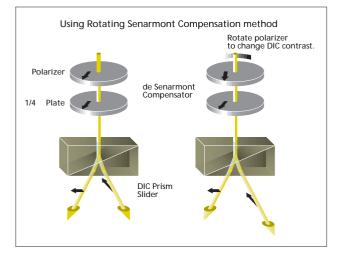
Nomarski DIC set

- DIC Polarizer
- Ø System Condenser Turret
- OIC Analyzer
- ELWD Condenser Lens
- 6 DIC Nosepiece
- 6 DIC Modules for System Condenser Turret
- DIC Sliders



Plan Fluor objectives

CFI Plan Fluor 10X
CFI Plan Fluor ELWD 20X C
CFI Plan Fluor ELWD 40X C



Senarmont method

The Senarmont method has been adopted to optimize comfort and performance in DIC microscopy. Contrast adjustment is accomplished by rotating the polarizer; this requires only a slight movement of the polarizer, eliminating the risk of annoying image shifts. In the new DIC system, the revolving nosepiece houses individual prisms for each objective so as to obtain optimal shear to match the N.A. of the condenser top lens and the objective.

High Resolution DIC



High N.A. condensers (dry, water, oil)

These condensers are essential to match the high numerical apertures of high magnification objectives. Three types of top lenses are available: an oil immersion type (N.A. 1.4), dry type (N.A. 0.85) and a water immersion type (N.A. 0.9). DIC sliders for CFI Plan Apo 100X oil, CFI Plan Apo 60X oil and CFI Plan Apo 60X water immersion objectives are also available.



- DIC Modules for Dry Top Lens
- 6 Oil Top Lens
- 6 DIC Module for Oil Top Lens

Epi-fluorescence/DIC



Epi-fluorescence/DIC set

- Epi-fl Attachment
- 2 Epi-fl Collector Lens
- Overcury Lamphouse with Mercury Lamp Socket and Mercury Lamp
- Epi-fl Filter Cubes and a Dummy Cassette
- 6 Centering Tool for Light Source
- 6 Light Shielding Plate
- Starter for Mercury Lamp
- 8 DIC Polarizer

- System Condenser Turret
- DIC Nosepiece
- DIC Analyzer
- DIC Modules for System Condenser Turret
- LWD or ELWD Condenser Lens
- 10 ND Filters
- FL Zoom Illumination Adapter
- Hand Switch
- Epi-fl Filter Rotating Turret
- DIC Sliders

Hoffman Modulation Contrast®

3D-relief-like observation is available with a plastic petri dish.



Hoffman Modulation Contrast[®] set

- Contrast Control Polarizer
- Ø System Condenser Turret
- HMC Condenser Lens
- 4 HMC Modules for HMC Lens
- LWD Condenser Lens
- 6 HMC Modules for LWD Lens
- HIVIC IVIOLUIES TOI LIVID LEIIS



HMC[®] condenser lens

A W.D. 44mm condenser lens gives more working distance to make demanding micromanipulation tasks like IVF more manageable.



HMC[®] objectives

A modulator inside the objective can change the contrast direction.

CFI HMC 10X

2 CFI LWD HMC 20X F

I CFI LWD HMC 40X C

HMC[®] with LWD system condenser lens

With W.D. 30mm, this condenser lens is most popular for HMC applications. It is also the same condenser that can be equipped for phase and DIC applications.

Phase Contrast

Apodized phase contrast objectives have been newly added to the lineup of conventional phase contrast objectives. With the new objectives, minute structures which were difficult to observe under halo can be clearly observed.





ADL objectives

- CFI Achromat ADL 10X (N.A. 0.25, W.D. 5.2mm) Ph1
- CFI Achromat LWD ADL20XF (N.A. 0.4, W.D. 3.0mm) Ph1
- 3 CFI Achromat LWD ADL40XF (N.A. 0.55, W.D. 2.1mm) Ph1
- G CFI Achromat LWD ADL 40XC (N.A. 0.55, W.D. 2.7-1.7mm) Ph2
- G CFI Plan Fluor ELWD ADL 20XC
- 6 CFI Plan Fluor ELWD ADL 40XC

Phase Contrast system condenser (ELWD, LWD)

System Condenser Turret
 ELWD Condenser Lens
 PhL for ELWD Lens
 Ph1 for ELWD Lens
 Ph1 for ELWD Lens
 LWD Condenser Lens
 LWD Condenser Lens
 PhL for LWD Lens
 Ph1 for LWD Lens
 Ph1 for LWD Lens
 Ph1 for LWD Lens
 Ph2 for LWD Lens
 Ph3 for LWD Lens





ELWD condenser

Excellent for phase contrast microscopy with 4X to 40X phase objectives. Its 65mm working distance and a 0.3 N.A. is sufficient for most applications and can be used with both the 100W and 30W illumination pillars.

SLWD condenser (for use only with the 30W illumination pillar)

Its long 190mm working distance permits observation through roller bottles or large flasks. A PhL phase ring is available for the 4X phase objective and a Ph1 phase ring for the 10X and 20X phase objectives.

Objectives List

Application	Туре	N.A.	W.D. (mm)	Cover glass thickness (mm)	Phase contrast ring
General-use Objectives for Phase	Contrast Observations				
chromat	CFI Achromat DL 10X	0.25	7.0	0.17	Ph1
	CFI Achromat LWD DL 20X F	0.4	3.1	1.2	Ph1
	CFI Achromat LWD DL 40X C	0.55	2.7–1.7	0-2.0	Ph2
shremet Leng Marking Distance	CFI Achromat ADL10X	0.25	6.2	1.2	Ph1
Achromat Long Working Distance	CFI Achromat LWD ADL20X F	0.4	3.1	1.2	Ph1
	CFI Achromat LWD ADL40X F	0.55	2.1	1.2	Ph1
	CFI Achromat LWD ADL40X C	0.55	2.7–1.7	0-2.0	Ph2
	CFI Plan Fluor DL 4X	0.13	16.4	1.2	PhL
law Flores	CFI Plan Fluor DL 10X	0.3	15.2	1.2	Ph1
lan Fluor	CFI Plan Fluor ELWD ADL 20X C	0.45	8.1–7.0	0-2.0	Ph1
	CFI Plan Fluor ELWD ADL 40X C	0.6	3.7–2.7	0-2.0	Ph2
	CFI Plan Fluor ELWD DM 20X C	0.45	8.1-7.0	0-2.0	Ph1
lan Fluor Long Working Distance	CFI Plan Fluor ELWD DM 20X C	0.43	3.7–2.7	0-2.0	Ph2
Ian Fluor Long Working Distance	CFI Plan Fluor ELWD DIM 40X C	0.0	2.1–1.5	0.5-1.5	Ph2
lan Fluor Oil	CFI Plan Fluor DLL 100X oil	1.3	0.2	0.17	Ph3
	CFI Plan Apochromat DM40X oil*	1.0	0.2	0.17	Ph3
	CFI Plan Apochromat DM40X oll	1.4	0.13	0.17	Ph3
lan Apochromat Oil	CFI Plan Apochromat DM100X oil	1.4	0.13	0.17	PH3
		1.4	0.13	0.17	PIIS
ligh-performance Objectives for	Fluorescence or DIC Observations				
	CFI Plan Fluor 4X	0.13	17.1	0.17	
	CFI Plan Fluor 10X	0.3	16.0	0.17	
lan Fluor	CFI Plan Fluor 20X	0.5	2.1	0.17	
	CFI Plan Fluor 40X	0.75	0.72	0.17	
	CFI Plan Fluor 60X C	0.85	0.3	0.11-0.23	
	CFI S Fluor 4X	0.2	15.5	0.17	
Fluor	CFI S Fluor 10X	0.5	1.2	0.17	
FILLOI	CFI S Fluor 20X	0.75	1.0	0.17	
	CFI S Fluor 40X C	0.9	0.3	0.11-0.23	
	CFI Plan Fluor ELWD 20X C	0.45	8.1-7.0	0-2.0	
lan Fluor Long Working Distance	CFI Plan Fluor ELWD 40X C	0.6	3.7–2.7	0-2.0	
gg	CFI Plan Fluor ELWD 60X C	0.7	2.1–1.5	0.5-1.5	
	CFI Plan Fluor 40X oil	1.3	0.2	0.17	
lan Fluor Oil	CFI Plan Fluor 100X oil	1.3	0.2	0.17	
	CFI Plan Fluor 100X oil with iris	0.5–1.3	0.2	0.17	
	CFI S Fluor 40X oil	1.3	0.22	0.17	
Fluor Oil	CFI S Fluor 100X oil, iris	0.5-1.3	0.2	0.17	
lan Apochromat Water	CFI Plan Apochromat 60X WI	1.2	0.22	0.15-0.18	
Ian Fluor Multi-immersion	CFI Plan Fluor 20X MI	0.75	0.35 (oil) 0.34 (glycerin) 0.33 (water)	0.13-0.10	
	CFI Plan Apochromat VC 60X oil	1.4	0.13	0.17	
lan Apochromat VC	CFI Plan Apochromat VC 100X oil	1.4	0.13	0.17	
	CFI Plan Apochromat VC 60X WI	1.4	0.13	0.15-0.18	
	CFI Plan Apochromat VC 60X WI	1.2	0.27	0.15-0.18	
lan Apochromat TIRF	CFI Plan Apochromat TIRF 60X OII CFI Plan Apochromat TIRF 100X oil	1.45	0.13	0.17	
		1.40	0.13	0.17	
loffman Modulation Contrast®	Objectives		1		
IMC	CFI HMC 10X	0.25	6.2	1.2	
	CFI HMC 10X CFI HMC LWD 20X F CFI HMC LWD 40X C	0.25 0.4 0.55	6.2 3.1 2.7–1.7	1.2 1.2 0–2.0	

Note: "C" denotes types with correction ring, *No objective lens slider is available with this objective.



Plan Apochromat VC



CFI S Fluor



Plan Apochromat TIRF





CFI Plan Apochromat 60X WI, CFI Plan Fluor 20X MI





Plan Fluor phase contrast

CFI Plan Fluor ADL

Hoffman Modulation Contrast®

New DIC Combinations for Inverted Microscopes

		System Condenser LWD Dry Motorized System Condenser LWD Dry		High NA Condenser Lens, Dry			High NA Condenser Lens, Oil				
		Standard High Contrast		Standard		Stan	Standard High Resolution		solution		
		Condenser Module	DIC Prism	Condenser Module	DIC Prism	Condenser Module	DIC Prism	Condenser Module	DIC Prism	Condenser Module	DIC Prism
ELWD	PF ELWD 20X C	LWD N1	T-C 20X I (PF ELWD 20XC)								
	PF ELWD 40X C	Dry	T-C 40X IV (PF ELWD 40XC)								
	PF ELWD 60X C		T-C 60X III (PF ELWD 60XC)								
10X	Plan Fluor 10X	LWD N1	10X								
	S Fluor 10X	Dry									
	Fluor 10X W										
20X	Plan Fluor 20X	LWD N2	20X	LWD N1	20X-C	HNA N2	20X	HNA N2	20X		
	Plan Apo 20X	Dry	207	Dry	20/10	Dry	207	Oil	207		
	S Fluor 20X										
	Plan Fluor 20X MI										
	Fluor 20X W										
40X	Plan Fluor 40X		40X I		40X I-C		40X I		40X I		
	Plan Apo 40X		10/11		10/11 0		10/11		107(1		
	S Fluor 40X										
	Plan Fluor 40X Oil		40X II				40X II		40X II		
	S Fluor 40X Oil										
	Fluor 40X W		40X Ⅲ				40X Ⅲ		40X Ⅲ		
	Plan Apo 40X Oil										
60X	Plan Apo 60X Oil A		60X I				60X I		60X I	HNA NR	60X I-R
	Plan Apo 60X		00711				00711		00711	Oil	
	Fluor 60X W									(2004.12)	
	Plan Apo VC 60X Oil										
	Plan Fluor 60X Oil		60X II				60X II		60X II		60X II-R
	Plan Apo TIRF 60X Oil										
	Plan Apo 60X W										
	Plan Apo VC 60X W										
	Plan Fluor 60X A										
100X	Plan Apo VC 100X Oil		100X I				100X I		100X I		100X I-R
	Plan Fluor 100X Oil		100X II				100X II		100X II		100X II-R
	Plan Fluor 100X Oil, iris										
	Plan Apo TIRF 100X										
	Plan Apo 100X NCG Oil										
	Plan Apo 100X Oil										

On sale from 2004.11

Epi-fluorescence Filters



Filter Cl	haracteristics					
	Filters	Wavelengths	Characteristics	Applications		
UV	UV-2A	EX 330-380 DM 400 BA 420	Standard filter block for UV			
	UV-2E/C (DAPI)	EX 340-380 DM 400 BA 435-485	For DAPI, cutting off FITC (green) and TRITC (red) Soft-coated type for high signal/noise Band-Pass Barrier Filter used to cut off green and red	•DAPI •Hoechst 33258/33342 •AMCA		
	UV-1A	EX 365/10 DM 400 BA 400	Narrow band pass – only 365nm (i line) of Mercury spectrum used Narrow band pass minimizes auto-fluorescence and photo-bleaching	•AMICA •Cascade Blue® •Autofluorescence		
	UV-2B	EX 330-380 DM 400 BA 435	Darker background than UV-2A			
v	V-2A	EX 380-420 DM 430 BA 450	Standard filter block for V	•Catecholamine •Serotonin •Tetracycline		
BV	BV-2A	EX 400-440 DM 455 BA 470	Standard filter block for BV	Quinacrine Quinacrine Mustard (QM)		
	BV-1A	EX 435/10 EM 455 BA 470	Narrow band pass – only 435nm (g line) of Mercury spectrum used Narrow band pass minimizes auto-fluorescence and photo-bleaching	•Thioflavine S •Acriflavine		
	B-3A	EX 420-490 DM 505 BA 520	•Wide band pass – recommended for halogen illumination only			
	B-2A	EX 450-490 DM 505 BA 520	•Standard filter block for B •For FITC + Counter-stain (TRITC, PI)	•FITC •Acridine Orange		
В	B-2E/C (FITC)	EX 465-495 DM 505 BA 515-555	 Soft coated type for high signal/noise For FITC (green), cutting off Rhodamine red Band-pass Barrier Filter used to cut off red 	•Auramine O •Coriphosphine O •Bodipy®		
	B-1A	EX 470-490 DM 505 BA 520	Narrower excitation range than B-2A FITC+Counter-stain (TRITC, PI)	•Fluo-3 •DIO		
	B-1E	EX 470-490 DM 505 BA 520-560	For FITC (green), cutting off Rhodamine redBand-Pass Barrier Filter used to cut off red			
G	G-2A	EX 510-560 DM 575 BA 590	Standard filter block for G			
	G-2E/C (TRITC)	EX 540/25 DM 565 BA 605/55	 For TRITC (Rhodamine) Soft coated type for high signal/noise Band-Pass Barrier Filter used to cut off reds above 643nm 	•TRITC •Rhodamine B200 •Propidium iodide •R-Phycoerythrin		
	G-1B	EX 546/10 DM 575 BA 590	Narrow band pass – only 546nm (e line) of Mercury spectrum used Narrow band pass minimizes auto-fluorescence and photo-bleaching	• R-Phycoerythrin • B-Phycoerythrin • Dil • Ethidium Bromide		
	G-2B	EX 510-560 DM 575 BA 610	•610nm barrier provides darker background and deep red emission			
Y	Y-2E/C (Texas Red)	EX 540-580 DM 595 BA 600-660	 For Texas Red[®] Soft coated type for high signal/noise Band-Pass Barrier Filter used to cut off reds above 660nm 	•Texas Red®		

Multi-Band Filters

Filters	Abbreviations	Applications
	F-R	FITC/Rhodamine
Dual	F-T	FITC/Texas Red
	D-F	DAPI/FITC
Triplo	D-F-R	DAPI/FITC/Rhodamine
Triple	D-F-T	DAPI/FITC/Texas Red

Filters for Fluorescent Protein

Models	Wavelengths	Characteristics	Applications			
GFP-L	EX480/40, DM505, BA510	GFP long-pass type	GFP			
GFP-B	EX480/40, DM505, BA535/50	GFP band-pass type	GFP			
High-quality Fluorescence Filters						
CFP-HQ	EX420-445, DM450, BA460-510	CFP narrow band-pass, high transmission	CFP			
GFP-HQ	EX455-485, DM495, BA500-545	GFP narrow band-pass, high transmission	GFP			
YFP-HQ	EX490-500, DM510, BA520-560	YFP narrow band-pass, high transmission	YFP			

Note: The lineup is constantly updated. For the latest information, please contact your local Nikon representative. The excitation filters or barrier filters in each filter cube are interchangeable. For custom setup, blank cubes without filters are also available. Please consult with your local Nikon distributor for a complete list of filters locally available or inquire about special custom filter combinations.

Accessories



Double lamphouse adapter

This adapter allows two different light sources to be attached to a single microscope. This eliminates the need to change the lamphouse and the troublesome centering procedures that are necessary. Switching between two lamphouses is possible even while they are turned on.

Multi-image module

Two accessories such as a video camera and a photomicrography system can be mounted simultaneously by means of this module.





Short vertical handle stage

This stage facilitates steady operation without contact to the handles when a camera is attached to the right-side port.

FX-III series photomicrographic equipment

The FX-III series utilizes a direct-projection system with a swingout prism for fast exposure setting and accurate metering. U-III: 0.1% and 1% spot exposure, and 35% integrated-average

measurement modes

H-III: 1% spot and 35% integrated-average measurement modes P-III: Manual exposure model



Teaching head

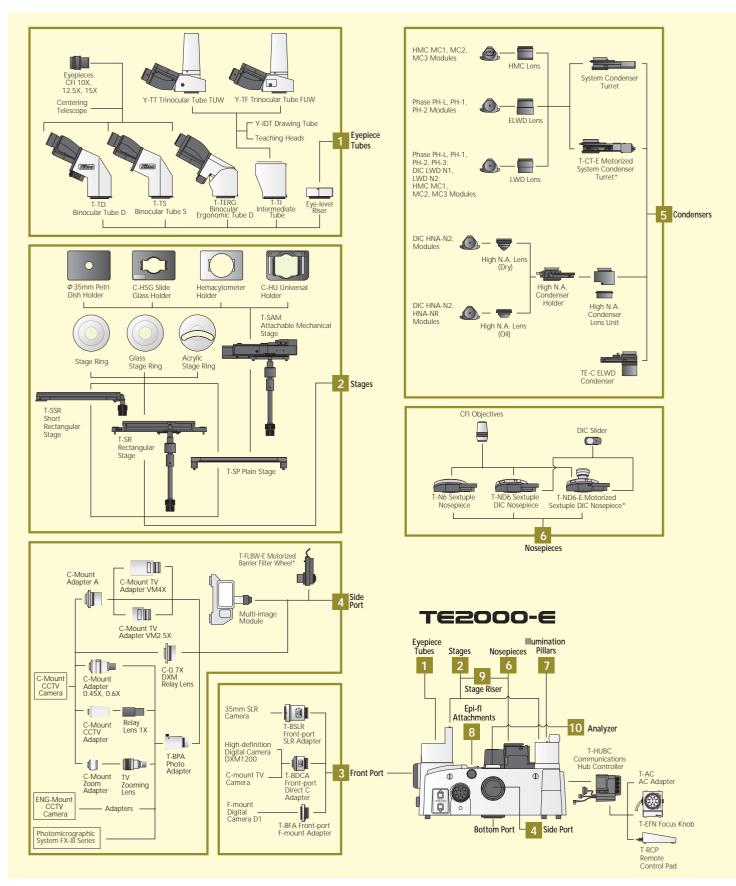
This option permits simultaneous observations of the same specimen by several persons, while delivering a constant degree of brightness. Ideal for education and training.

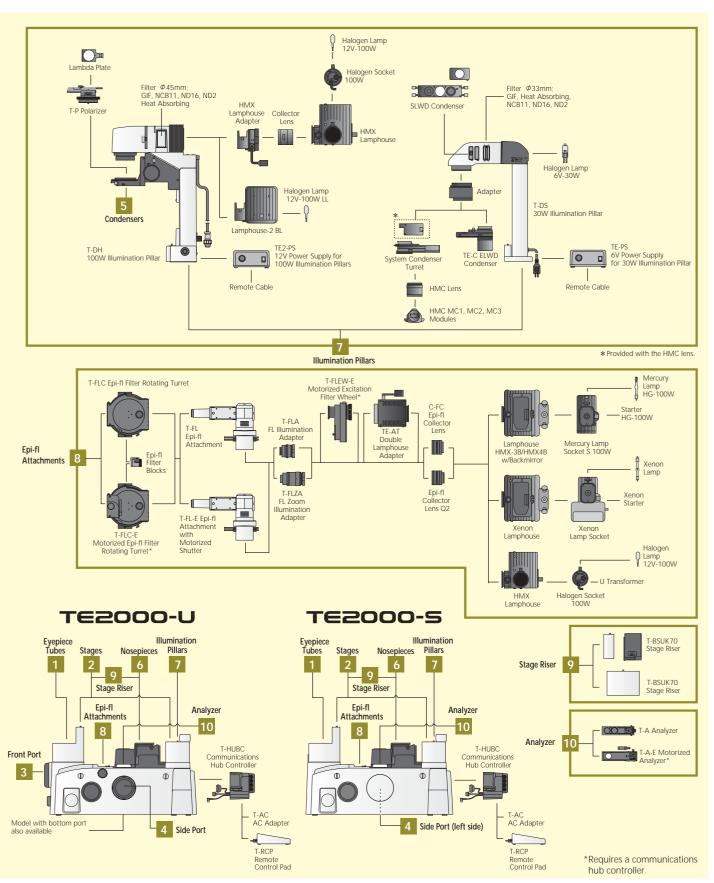


CCTV adapters

2.5X, 4X relay lenses are ideal for video enhanced contrast (VEC applications). Use 0.35X, 0.45X and 0.7X relay lenses for 1/3-, 1/2-, 2/3-inch CCD cameras, respectively. 0.9 to 2.2X zoom relay lenses are also available.

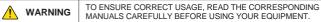
System Diagram

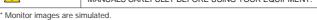




Please contact Nikon for a handy pamphlet listing compatible accessories, including objectives and epi-fluorescence filters.

Specifications and equipment are subject to change without any notice or obligation on the part of the manufacturer. November 2004. ©2004 NIKON CORPORATION





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